



**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2825**

PATENT

Customer No. 22,852

Attorney Docket No. 2887.0259-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Junji SUGAMOTO et al.)	Group Art Unit: 2891
)	
Application No.: 10/706,090)	Examiner: LEE, Granvill D.
)	
Filed: November 13, 2003)	Confirmation No.: 7292
)	
For: SEMICONDUCTOR WAFER)	
TREATMENT METHOD,)	
SEMICONDUCTOR WAFER)	
INSPECTION METHOD,)	
SEMICONDUCTOR DEVICE)	
DEVELOPMENT METHOD AND)	
SEMICONDUCTOR DEVICE)	
TREATMENT APPARATUS)	

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION

In reply to the Final Office Action mailed March 23, 2005, the period for response to which having been extended through August 23, 2005, by a Petition for Extension of Two Months Time and fee payment filed concurrently herewith, Applicants respectfully request reconsideration of this application.

Remarks begin at page 2 of this paper.